**TECHNOLOGY CENTER R3700** 

## IN THE STATES PATENT AND TRADEMARK OFFICE

In re Applica	tion of:	)	
David P. WI	ECZOREK et al.,	)	
Application No.: 09/482,060			Group Art Unit: 3752
Filed: Janua	ry 13, 2000	)	Examiner: Kim, C.
For: FUEI	LINJECTOR TEMPERATURE	)	
STAI MET	BILIZING ARRANGEMENT AND HOD	)	RECEIVED
			SEP 1 8 2002
Commissioner for Patents			TEQUINOLOCY CENTED DOTA

Sir:

## REQUEST FOR APPROVAL OF NEW DRAWINGS

Subject to the approval of the Examiner, it is respectfully requested that NEW Figures 4A and 4B. No new matter is believed to be entered by entry of the drawing corrections.

Applicants request approval of NEW Figures 4A and 4B. Upon approval by the Examiner, Applicants respectfully request abeyance of corrected Formal Drawings pending a Notice of Allowance.

Respectfully submitted,

**MORGAN, LEWIS & BOCKIUS** 

By:

Khoi Q. Ta

Reg. No. 47,300

Dated: 13 September 2002

Washington, D.C. 20231

MORGAN, LEWIS & BOCKIUS LLP 1111 Pennsylvania Avenue, N.W. Washington, DC 20004 202-739-3000